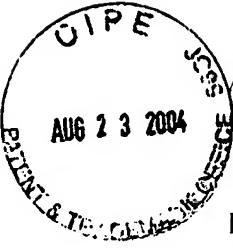


8-24-04

IFW



Attorney's Docket No. 5697.57CT

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: DeYoung, et al. Group Art Unit: 1746
Serial No. 10/659,842 Examiner: Bibi S. Carrillo
Filed: 09/10/2003 Confirmation No.: 5522

For: METHODS AND COMPOSITIONS FOR ETCH CLEANING
MICROELECTRONIC SUBSTRATES IN CARBON DIOXIDE

August 23, 2004

Mail Stop Amendment
Commissioner for Patents
Post Office Box 1450
Alexandria, Virginia 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

The present Amendment is in response to the Official Action mailed July 23, 2004.

It is not believed that an extension of time and/or additional fee(s), including fees for additional claims, are required, beyond those that may otherwise be provided for in documents accompanying this paper. In the event, however, that an extension of time is necessary to allow consideration of this paper, such an extension is hereby petitioned under 37 C.F.R. §1.136(a). Any additional fees believed to be due in connection with this paper may be charged to our Deposit Account No. 50-0220.

CERTIFICATE OF EXPRESS MAILING

Express Mail Label No.: EV 472538807 US

Date of Deposit: August 23, 2004

I hereby certify that this correspondence is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and is addressed to: Mail Stop Amendment, Commissioner for Patents, Post Office Box 1450, Alexandria, Virginia 22313-1450.



Cathy A. Schetzina